

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/812,347	HIGUCHI ET AL.	
Examiner	Art Unit	
Kin-Chan Chen	1765	

SEARCHED					
Class	Subclass	Date	Examiner		
438	706	1/5/2006	ксс		
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216	63		*		
216	74	15/2006	kcc		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East Keyword search USPST, USPG-PM. EPO, JPO, Derwent TBM-TOB, Inventor search	1/5/2006	ксс		
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